Attorney's Docket No.: 42390.P8136

Patent



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Patent Application of

CADIEN

Examiner: Chen, L.

Application No. 09/473,391

Art Unit: 1765

Filing Date: December 28, 1999

For:

ABRASIVES FOR CHEMICAL

MECHANICAL POLISHING issioner for Patents

Commissioner for Patents Washington, D.C. 20231

#6 7/6/01 MW

JUL -3 2001 C 1700 MAIL ROOM

PETITION FOR EXTENSION OF TIME Pursuant To 37 C.F.R. § 1.136

Sir:

Applicants respectfully request a four month extension of time in which to respond to the January 31, 2001 Office Action for which a one month shortened statutory response period expiring on February 28, 2001 was set. The extended period expires on June 28, 2001.

A check for \$1,390.00 is enclosed to cover the fee for a four month extension of time. If any additional fee is required, please charge Deposit Account No. 02-2666. A duplicate of this Petition is enclosed for deposit account charging purposes.

Respectfully submitted,

07/02/2001 JADD01

00000031 09473391

01 FC:118

1390.00 OP

BLAKELY, SOKOLOFF, TAYLOR & ZAFMAN LLP

Date: $U/\gamma\gamma$

Edwin H. Taylor

Customer No.: 008791 12400 Wilshire Blvd.

Seventh Floor

Los Angeles, CA 90025

(408) 720-8598

Registration No.: 25, 129

Certificate of First Class Mailing

I hereby certify that this correspondence is being deposited with the United States
Postal Service as first class mail with sufficient postage in an envelope addressed to
the Commissioner for Patents, Washington, D.C. 20231

on Que 22 2001.	
Date of Deposit	
Kelli Tren	
Name of Person Mailing Correspondence	/ 22 \\
Kelli Men	<u> </u>
Signature	Date

Docket No.: 42390.P8136